

SEMICONDUCTOR PRODUCTION APPARATUS AND INSTALLATION METHOD

ABSTRACT

A semiconductor production apparatus is a semiconductor production apparatus for producing a semiconductor, and includes an accommodated object installed inside an apparatus frame of the semiconductor production apparatus, and a holding member accommodated inside the apparatus frame together with the accommodated object and configured to hold the accommodated object. The holding member includes a base body, an attachment body attached to a lower portion of the accommodated object, and a lifting structure provided between the base body and the attachment body and configured to lift the attachment body from the base body.

Figure 5